

IN THE UNITED STATES PATENT AND TRADEMARK OFFICERECEIVED  
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Inventors: Han-Hsing Liu

Assignee: Winbond Electronics Corporation

Title: Polycide Gate Structure and Manufacturing Method Thereof

Serial No.: 10/748,828 Filing Date: December 29, 2003

Examiner: Dung Anh Le Group Art Unit: 2818

Docket No.: DAF009 US Confirmation No.: 7167

JUN 15 2006

Santa Clara, California  
June 15, 2006

Mail Stop Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Entered  
with  
RCE  
6/15/06

RESPONSE TO OFFICE ACTION

Dear Sir:

This Response to Office Action is responsive to the March 17, 2006, final Office Action, which has a statutorily shortened period for response that ends June 17, 2006. A Request for Continued Examination is attached hereto. Please enter the following amendments before taking action on the merits of the above-referenced application.

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